

49 48708

EAST - [resistor.wap.1] 2/17/93

File View Edit Database Help

Active

- L1: (2) (("6746899") or ("6737704")).PN.
- L2: (4) (("6,278,148") or ("6,218,631") or ("5,610,403") or ("5,
- L3: (6) "6458674".
- L4: (1) ("6458674").PN.
- L5: (10) (("6324091") or ("6320200") or ("6348700") or ("4663270
- L6: (7) 5 and organic
- L7: (7) 5 and (organic or polymer)
- L8: (0) 7 and (silicon\$5 with (resist or mask or photoresist))
- L9: (2) 7 and (resist or mask or photoresist)
- L10: (160890) electrode.clm.
- L11: (14192) 10 and (organic or polymer).clm.
- L12: (1241) 11 and (resist or photoresist or mask).clm.
- L13: (983) 12 and (pattern\$3 or etch\$3).clm.
- L14: (408) 13 and ((resist or photoresist or mask) with (silicon
- L15: (201) 14 and ((organic or polymer) with electrode)
- L16: (199) 15 and ((etch\$3 or pattern\$3) with (electrode or orga
- L17: (199) 15 and ((etch\$3 or pattern\$3) same (electrode or orga
- L18: (62) 17 and (memory or ((second or top or upper) adj electr
- L19: (62) 18 and (resist or mask or photoresist).clm.
- L20: (62) 19 and (etch\$3 or pattern\$3).clm.
- L21: (62) 20 and ((etch\$3 or pattern\$3) near10 (resist or mask o
- L22: (60) 20 and ((etch\$3 or pattern\$3) near10 (organic or polym
- L23: (59) 22 and ((etch\$3 or pattern\$3) near5 (organic or polyme
- L24: (29) 23 and polymer
- L25: (7) 12 and (polysiloxane or silsesquioxane)
- L26: (1) 11 and ((resist or photoresist or mask) with (polysilox
- L27: (463) 12 and ((resist or mask or photoresist) near8 (silico
- L28: (178) 27 and (organic with electrode)
- L29: (178) 28 and (organic or polymer).clm.
- L30: (129) 29 and ((organic or polymer) near8 electrode)
- L31: (40) 30 and ((top or second or upper) adj electrode)
- L32: (16) 31 and dielectric
- L33: (37) 31 and ((top or second or upper) adj electrode).clm.
- L34: (32) 33 and (etch\$3 or pattern\$3).clm.
- L35: (32) 34 and (resist or mask or photoresist).clm.

Failed

Saved

34 and (resist or mask or photoresist).clm.

Document ID Issue Date Pages Title Current OP Current KR Retrieval Inventor

1	US	20040415	50	Light emitting device	438/30			Yamazaki, Shunpei					
2	US	20040072380		and method for manufact				et al.					
3	US	20040325	30	Method for etching	438/710			Higuchi, Kenichi					

Page 1